	earch Notes					

Application/Control No.	Applicant(s)/Patent under Reexamination
10/720,390	YOUN, KI-CHO
Examiner	Art Unit
Seung H. Lee	2876

	SEARCHED				
Class	Subclass	Date	Examiner		
705	43	12/21/2005	SHL		
902	8,9	12/21/2005	SHL		
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
235	379	12/21/2005	SHL	
705	43	12/21/2005	SHL	
902	8,9	12/21/2005	SHL	

SEARCH NOT (INCLUDING SEARCH		)
	DATE	EXMR
235/379 (see Printouts)	12/21/2005	SHL
PCT cites	12/21/2005	SHL
Korea Institute of Patent Information	12/20/2005	SHL